Announcement of Retraction

The editorial board announced this article has been retracted on December 21, 2015.

If you have any further question, please contact us at: jmsr@ccsenet.org

Article Title: Synthesis and Properties of Electrochemically Deposited Vertical Mesoporous Silica Thin

Films

Author/s: Yuan Zhou, Qiming Liu, Ye Feng & Min Tan Journal Title: Journal of Materials Science Research

ISSN 1927-0585 E-ISSN 1927-0593 Volume and Number: Vol. 3, No. 4, 2015

Pages: 31-37

DOI: 10.5539/jmsr.v3n4p31